



**UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **Tadashi WATANABE et al.**

Art Unit: **2818**

Application Number: **10/823,729**

Examiner: **David Vu**

Filed: **April 14, 2004**

Confirmation Number: **5344**

For: **SEMICONDUCTOR DEVICE FABRICATION METHOD**

Attorney Docket Number: **042341**

Customer Number: **38834**

**AMENDMENT UNDER 37 C.F.R. §1.111**

**Mail Stop: Amendment**

Commissioner for Patents

P. O. Box 1450

Alexandria, VA 22313-1450

May 27, 2008

Sir:

This paper is filed in response to the Office Action dated January 25, 2008.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 7 of this paper.